

Form PTO 1449  
US DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

Atty Docket No. 789\_064

Serial No. 09/749,252

Applicant Yukihiisa TAKEUCHI, Tsutomu NANATAKI, Natsumi SHIMOGAWA and Takayoshi AKAO

Filing Date December 27, 2000

Group

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

MAY 29 2001

### U.S. PATENT DOCUMENTS

Exam. Initial	Document Number	Date	Name	Class	Sub Class	Filing Date
T.T.	AA 5,862,275	1/19/1999	Takeuchi et al. /	/	/	/
T.T.	AB 5,636,072	6/3/1997	Shibata et al.	/	/	/
T.T.	AC 5,774,257	6/30/1998	Shibata et al.	/	/	/
T.T.	AD 6,028,978	2/22/2000	Takeuchi et al.	/	/	/
TT	AE 4,113,360	9/12/1978	Baur et al.	/	/	/
T.T.	AF 5,771,321	6/23/1998	Stern	/	/	/
T.T.	AG 5,953,469	9/14/1999	Zhou	/	/	/
T.T.	AH 6,091,182	7/18/2000	Takeuchi et al.	/	/	/
T.T.	AI 6,108,479	8/22/2000	Takeuchi et al.	/	/	/

### FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	Translation	Abstract
T.T. AJ 0 675 477 A1	10/4/1995	EP	/	/	✓	
T.T. AK 54-142089	5/11/1979	JP	/	/		✓
T.T. AL 7-287176	10/31/1995	JP	/	/		✓
T.T. AM 11-202222	7/30/1999	JP	/	/		✓
T.T. AN 11-72721	3/16/1999	JP	/	/		✓
T.T. AO 0 408 305 B1	3/13/1996	EP	/	/	✓	

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages Etc.)

T.T.	AP	Kazuo Anzai, "Preparation of Electronic Materials by Electrophoretic Deposition," General Institute of Toshiba Corporation, Denki Kagaku 53, No. 1, 1985, pp 63-68.
T.T.	AQ	Atsushi Goto et al., $PbZrO_3/PbTiO_3$ Composite Ceramics Fabricated by Electrophoretic Deposition," Tokyo Metropolitan University, Tokyo Medical and Dental University, Proceedings of First Symposium on Higher-Order Ceramic Formation Method Based on Electrophoresis, 1998, pp 5 and 6.
T.T.	AR	Kimihiro Yamashita, "Hybridization of Ceramics by Electrophoretic Deposition," Institute for Medical and Dental Engineering, Tokyo Medical and Dental University, Proceedings of First Symposium on Higher-Order Ceramic Formation Method Based on Electrophoresis, 1998, pp 23-24.
Examiner TUYEN TRA		Date Considered 3-17-02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.